## OCTOS™ 6

# Robotic Cluster Tool Distribution Vessel



### Kurt J. Lesker®



#### **Applications**

- The OCTOS<sup>™</sup> 6 robotic cluster tool facilitates accurate and repeatable multi chamber in-vacuum substrate transfer-ideal for R&D and pilot production applications.
- Fully automated with recipe control and is designed to accept standard, KJLC process modules. In addition, fully interconnected, independent control of each process module can be supplied, becoming a true multi-user installation.

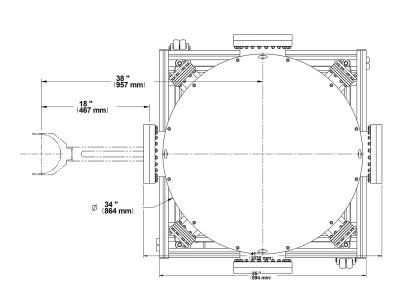
#### **Features**

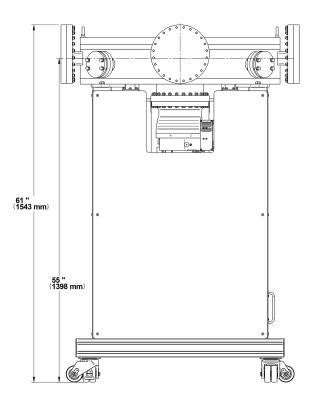
- · High precision servo-controlled robot
- Robot MTBF >80,000 hours
- Stainless steel vacuum vessel construction with o-ring sealed top plate
- Modular framework
- Cryogenic or turbomolecular high vacuum pumping
- Accommodates up to 6" (150 mm) substrates
- · Fully automated computer control
- · CF process chamber ports

#### **Options**

- Standard KJLC PVD process modules (magnetron sputtering, thermal evaporation, e-beam evaporation)
- · Single or multi wafer load lock modules
- · Glovebox integration
- Transfer to 3rd party process modules
- · Standard KJLC ALD module

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Dimensions Approximate

#### **Specifications**

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Number of Transfer Ports	Up to 6
Transfer Mechanism	Genmark AVR Robot
Cycle Time	20 sec
Substrate Size (max)	6" (150 mm) Diameter or Square
R-axis (vessel center to transfer fork center)	34" (864 mm) with 6" Transfer Forks
Transfer Height (from floor)	44" (1118 mm)
Z-axis (vertical)	1" (25.4 mm)
Linear Repeatability	±.001" (.025 mm)
Angular Repeatability	±.01°
Vertical Repeatability	±.001" (.025 mm)
Maximum Payload	5 lb (2.27 kg)
Internal Wafer Storage	No
Load Lock Compatible	Yes
Vacuum Pumping	Turbo or Cryo Pump with Dry Backing Pump
Base Pressure (CDE)	5 X 10 <sup>-7</sup> Torr or Lower
System Control	PC-Based Control System
Available Certifications	NRTL, CSA, CE, Others on Request
Weight (approx)	1,100 lbs (499 kg)

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